INTERNATIONAL GEMOLOGICAL INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

February 20, 2026

IGI Report Number	LG775628702
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	RECTANGULAR CUSHION MIXED CUT
Measurements	8.68 X 5.91 X 3.94 MM

GRADING RESULTS

Carat Weight	1.92 CARAT
Color Grade	E
Clarity Grade	VVS 2

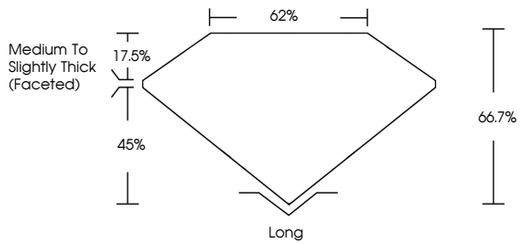
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG775628702

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG775628702
Report verification at igi.org

PROPORTIONS



Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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www.igi.org

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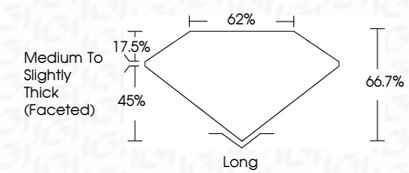

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IGI

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IGI Report No LG775628702
RECTANGULAR CUSHION MIXED CUT
8.68 X 5.91 X 3.94 MM

Carat Weight	1.92 CARAT
Color Grade	E
Clarity Grade	VVS 2
Depth	66.7%
Table	62%
Girdle	Medium To Slightly Thick (Faceted)
Culet	Long
Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG775628702

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